

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	)	Confirmation No.: 7371
Shunpei YAMAZAKI et al.	)	
Application No. 09/295,607	)	Examiner: Shouixiang Hu
Filed: April 22, 1999	)	Group Art Unit: 2811
For: SEMICONDUCTOR DEVICE HAVING	)	Date: April 22, 2008
ALUMINUM NITRIDE FILM	)	

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

The undersigned certifies that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in connection with a counterpart foreign application not more than three (3) months prior to the filing of this statement.

It should be noted that U.S. Patent No. 4,755,478 is in the family of JP 01-133368 and EP 0 303 061; U.S. Patent No. 5,414,278 is in the family of JP 05-011271; and U.S. Patent Nos. 5,637,187 and 6,067,062 are in the family of JP 04-133035 and EP 0 474 474.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form and return it to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

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